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# Direct Conversion of D-<sup>3</sup>He Protons Using a Silicon PIN Junction Diode



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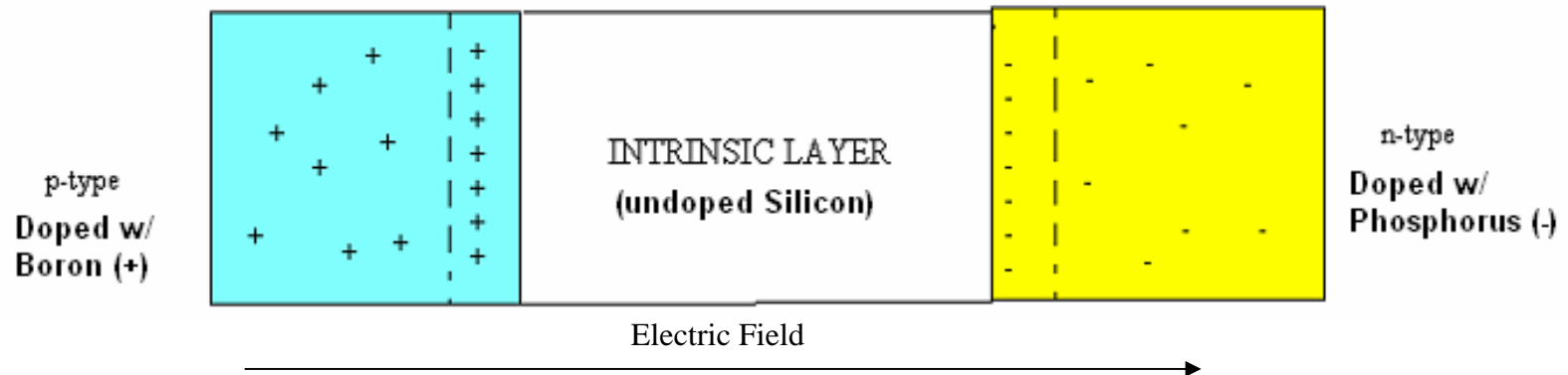
**8<sup>th</sup> US-Japan IEC Workshop  
University of Kansai**

# Project Goals

- Proof of principle for using a solid state device as a means to convert D-<sup>3</sup>He fusion protons to electric power
- Measure the efficiency of such a device and compare with theoretical predictions
- Characterize the damage induced in such a device under proton fluxes similar to those in a power reactor.

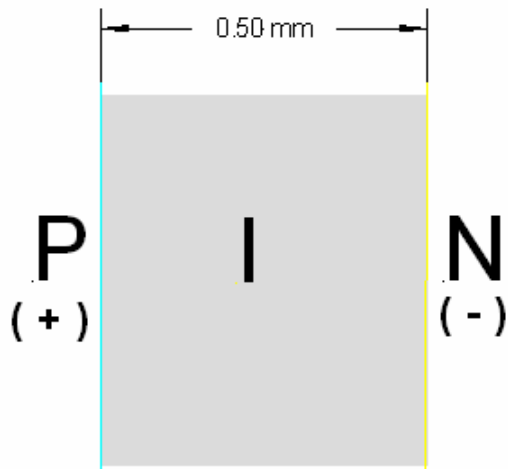
# Direct Conversion Theory

- Semiconductor devices have a inherent voltage drop due to p-type and n-type dopant. Charge carriers ( $e^-$  / holes $[+]$ ) induced in the semiconductor will move in



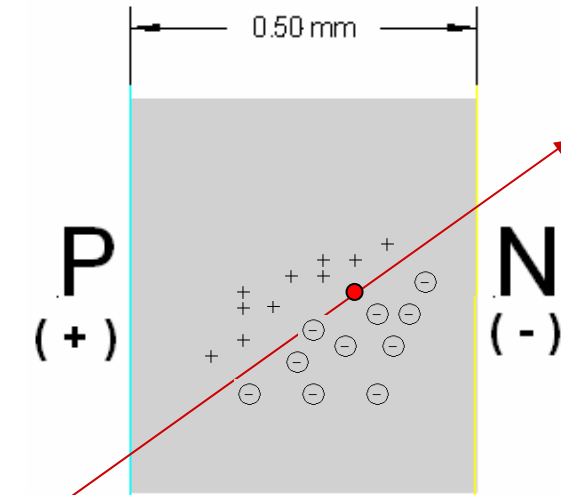
Inherent Voltage drop creates a built in Electric field which creates an electric current from any charge carriers created from incoming radiation.

# Direct Conversion Theory Continued



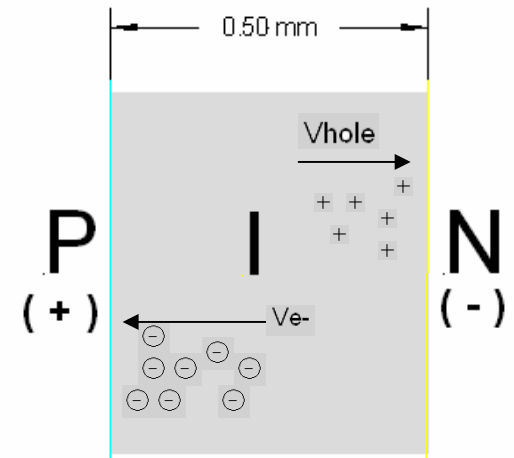
Pre-proton impact

- P-positive dopant (boron)
- I-intrinsic (pure) silicon
- N-negative dopant (phosphorus)



14.7 MeV proton  
impact

- Electronic Stopping of the proton causes formation of e<sup>-</sup>/hole pairs in Silicon



Post proton impact

- Either the inherent voltage across the PIN junction or an applied voltage will cause the electrons and holes to move, inducing a current

# Efficiency of Direct Conversion

- The following defines the expected efficiency of the PIN diode energy conversion scheme.
- $V_{diode}$  = Effective voltage drop of diode (max @ inherent voltage [ $\sim 1V$  in Si])
  - Typically  $V_{diode} \sim 0.7V_{inherent}$
  - Dopant concentration has a significant effect on  $V_{inherent}$
- $\gamma \equiv$  proton flux (protons/cm<sup>2</sup>s)
- $E_{pair} \equiv$  Energy required to create e<sup>-</sup>/hole pair in Si (3.62eV – Knoll [Table 11.1])
- $E_p \equiv$  Energy of incident proton
- The following calculation is with Si:

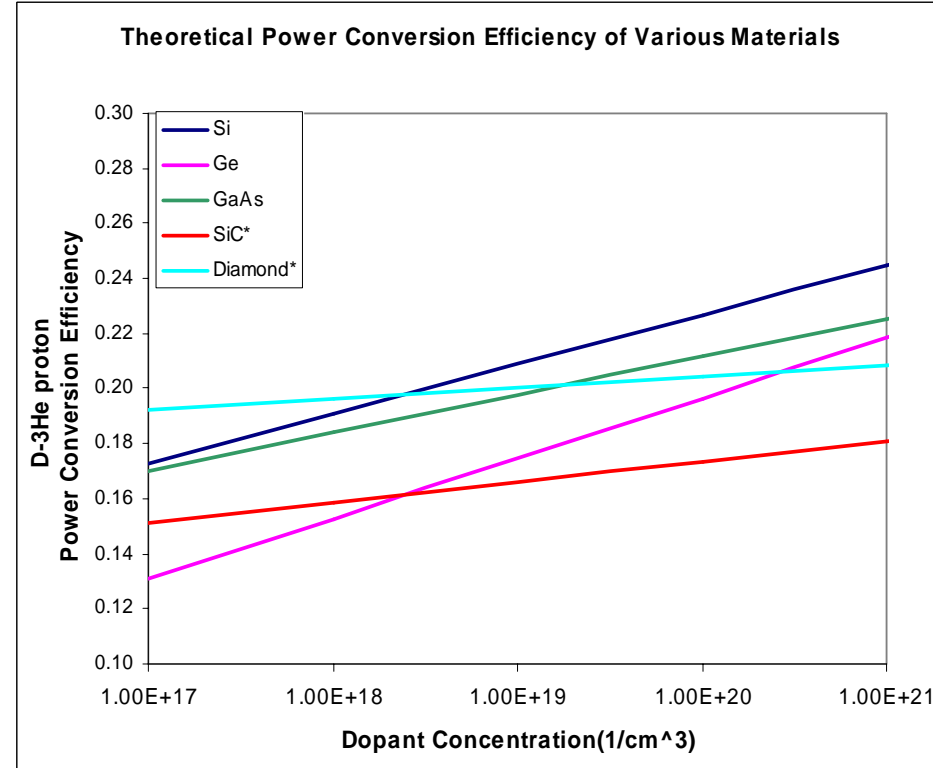
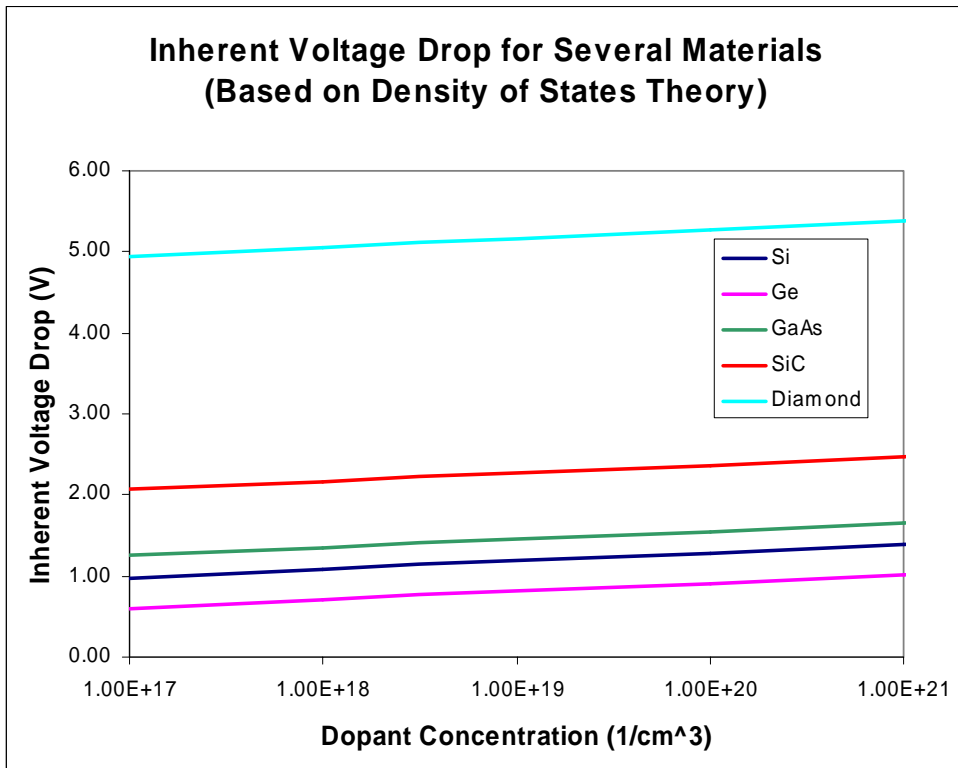
Material	Si	Ge	GaAs	SiC	Diamond
$V_{inherent}(V)$	1.1	0.7	1.4	2.4	5.5
$E_{pair}(eV)$	3.6	3.0	4.7	8.8	16.5
$V_{diode}(V)$	0.7	0.4	0.9	1.5	3.5

$$P_{in} = \gamma e E_p (eV)$$

$$P_{out} = V_{diode} (Volts) \frac{\gamma e E_p (eV)}{E_{pair} (eV)}$$

$$\eta = \frac{P_{out}}{P_{in}} = \frac{V_{diode}}{E_{pair}} \approx \frac{0.7(Volts)}{3.62(Volts)} = 19\%$$

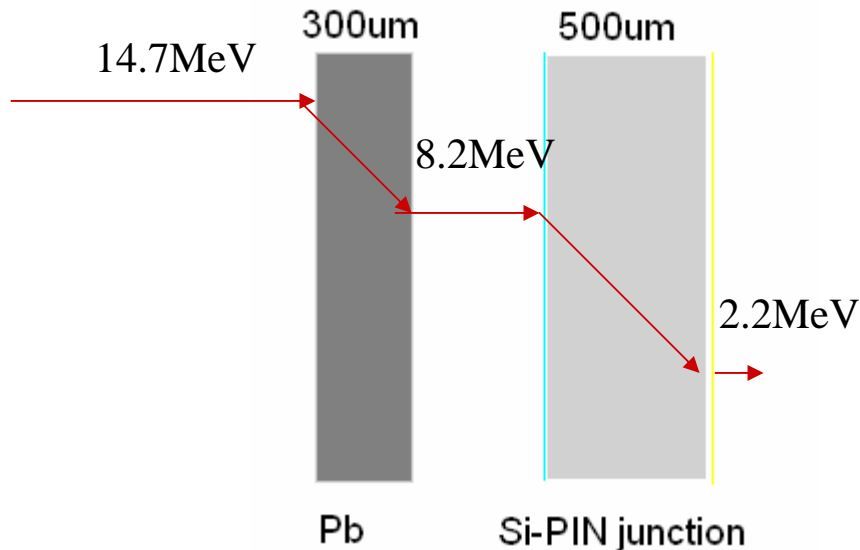
# Direct Conversion Efficiency Depends on “Inherent Voltage Drop” and e<sup>-</sup>/hole Pair Creation Energy



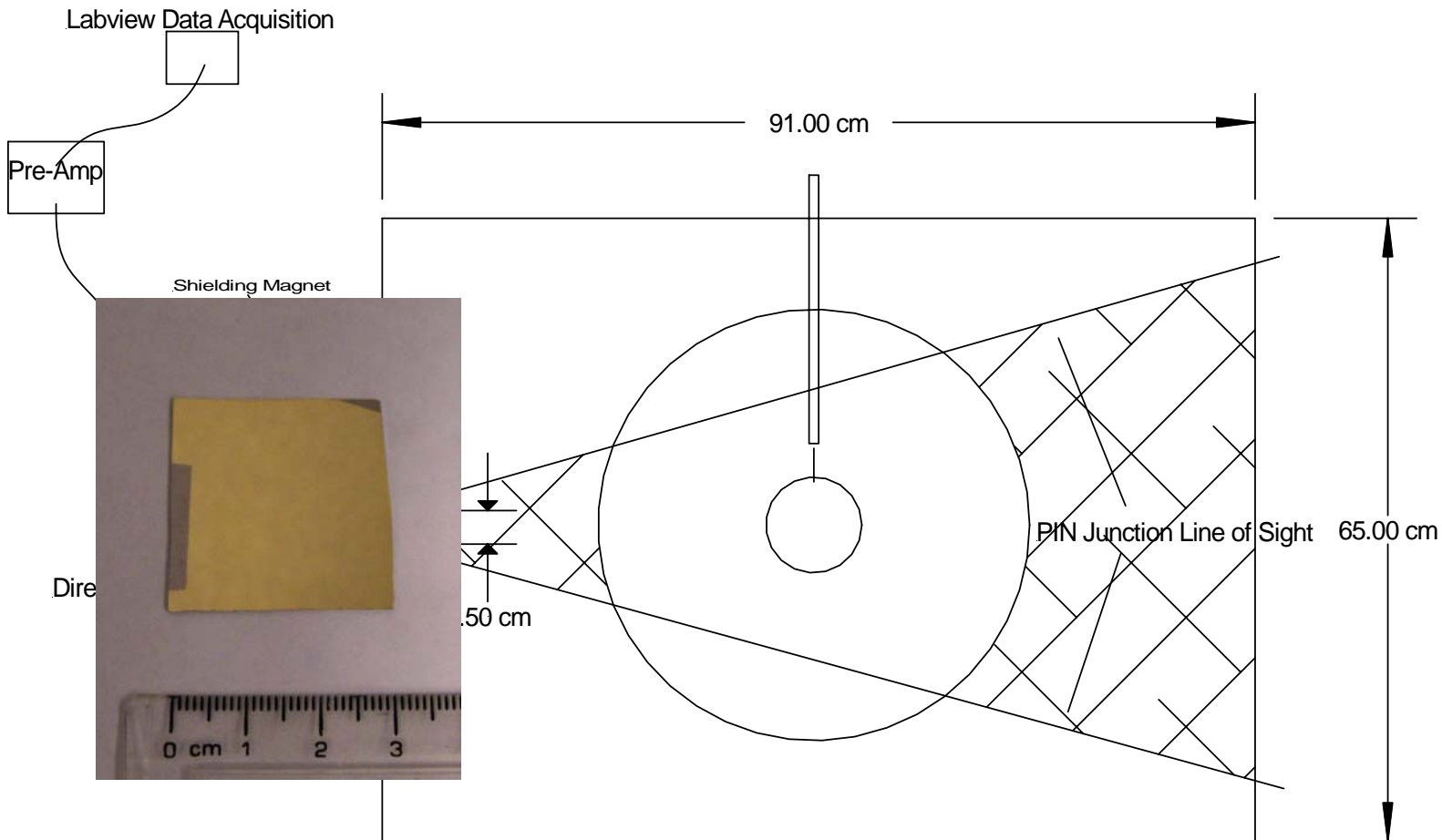
Theoretical Efficiencies for solid state devices range from ~10% - 25% over a range dopant concentrations.

# Configuration of UW-IEC D-<sup>3</sup>He Proton Direct Conversion Experiment

- Current PIN junction configuration
  - 300um Pb shield (X-Ray shielding)
  - 500um Si PIN junction diode (to limit damage at end of trajectory)
- This utilizes about 6MeV of 14.7MeV available in the D-3He proton.
- PIN diode face is 10cm<sup>2</sup> → ~1nA of current with IEC proton rates of 1x10<sup>7</sup>



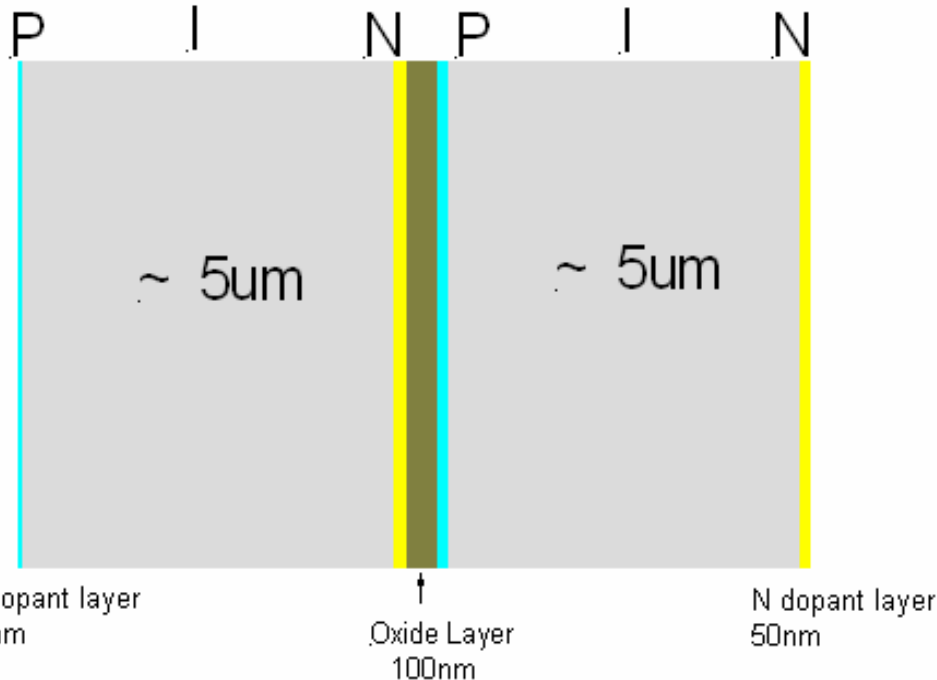
# Configuration of UW-IEC D-<sup>3</sup>He Proton Direct Conversion Experiment





# PROBLEM: Charge Carrier Lifetime can Limit the Usefulness of 500 $\mu$ m Thick PIN Junction Design

- Typical lifetimes of e<sup>-</sup>/hole in Si is  $\sim 10\text{-}100 \mu$  s.
- $V_{\text{inherent}} = 1\text{V} \rightarrow$  E-field = 2000V/cm (in a 500  $\mu$  m thick PIN junction)
- In a 2000V/cm E-field a charge carrier spends  $\sim 10\text{-}20 \mu$  s in the junction. (Recombination is possible)



**Solution:**  
By layering smaller junctions in series or in parallel this problem can be avoided.

# Conversion Efficiency and Proton Damage Effects will be Measured

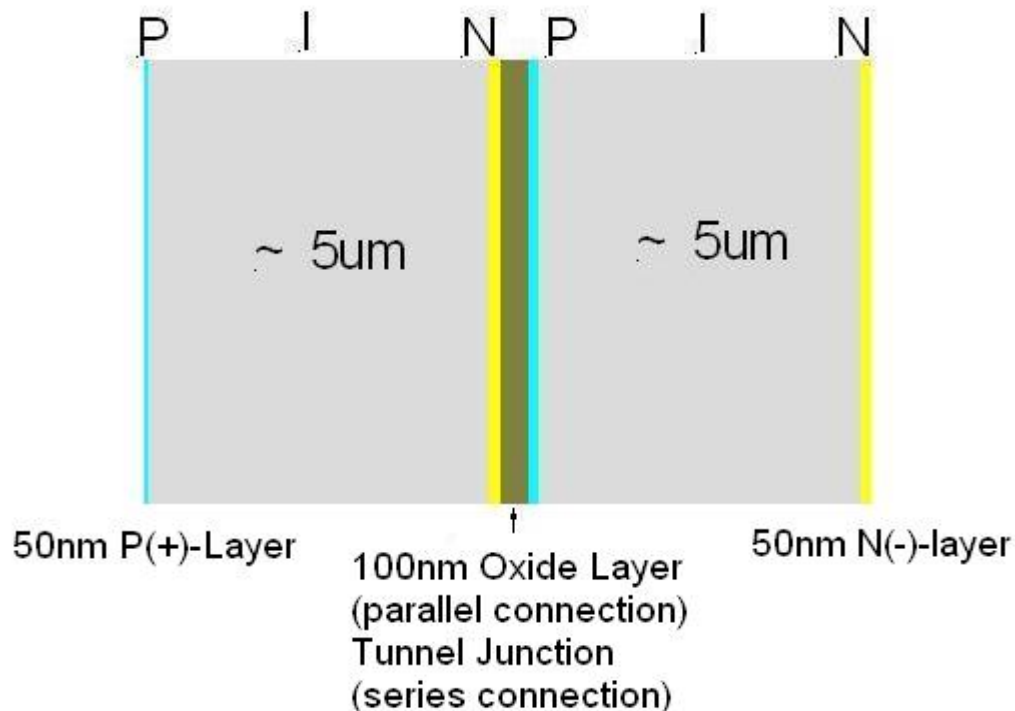
- Once principle has been proven on IEC device a 3MeV linear accelerator will be used for:
  - Measuring the efficiency of PIN junction technique
  - Examining the effect of radiation damage on conversion efficiency and device performance.

# Summary

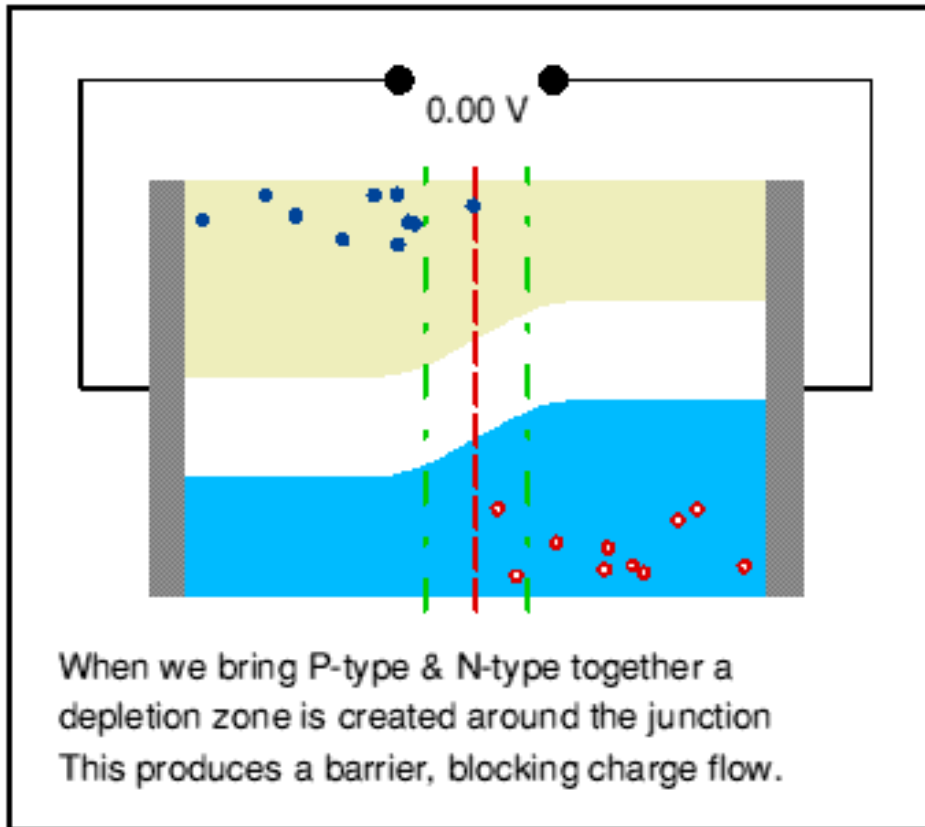
- The theoretical efficiency of a PIN junction direction energy conversion device has been calculated to be ~20%
- An experiment is in progress at the University of Wisconsin to prove the principle of using a PIN junction to convert D-<sup>3</sup>He protons to electric power.
- Future experiments are planned to measure the efficiency of a PIN junction converter and analyze the degradation of device performance due to radiation damage from protons.

# Future Work

- Efficiency and radiation damage measurements on accelerator have yet to be done.
- Multi-junction design would be more useful for power conversion applications. This design is more expensive to fabricate but should eventually be tested.



# How a Diode Works

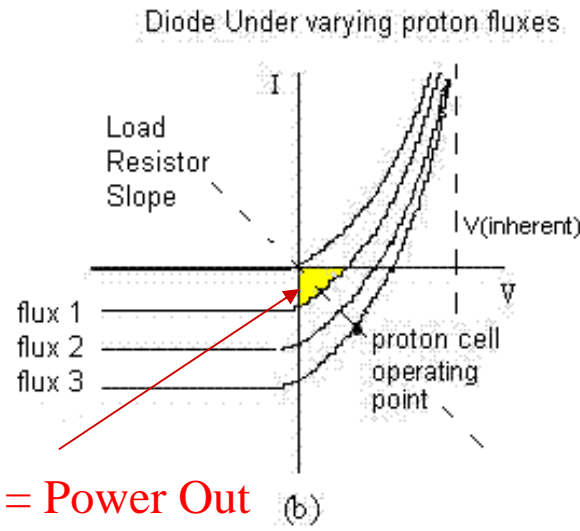
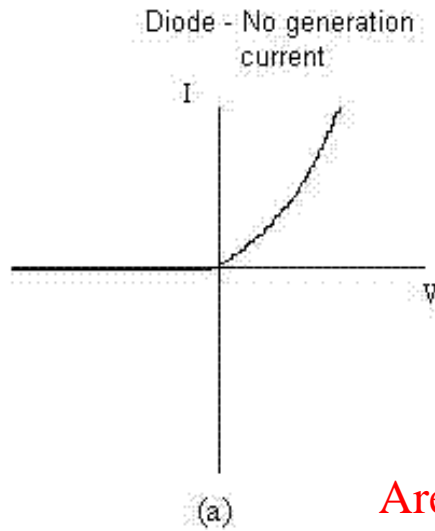


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- Proton Detectors operate in reverse bias mode
- Direct Conversion depends on inherent voltage drop with 0V applied.

# Theoretical Power Conversion Efficiency is Affected by Real Diode Characteristics

Real PIN Diode Characteristics



Area = Power Out

$$P_{real} \sim 0.7P_{ideal}$$

Ideal PIN Diode Characteristics

